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Substitute for form 1449A/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Sheet 1 of 8

Complete if Known

Application Number 10/788,685
Filing Date 02/27/2004
First Named Inventor Choi et al.
Group Art Unit 1756
Examiner Name Young, Christopher G.
Attorney Docket Number PA130-06D09

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
Cuy	A1	4,070,116		Frosch et al.	01-24-1978	
	A2	4,600,309		Fay	07-15-1986	
	A3	4,848,911		Uchida et al.	07-18-1989	
	A4	5,074,667		Miyatake	12-24-1991	
	A5	5,148,036		Matsugu et al.	09-15-1992	
	A6	5,148,037		Suda et al.	09-15-1992	
	A7	5,151,754		Ishibashi et al.	09-29-1992	
	A8	5,179,863		Uchida et al.	01-19-1993	
	A9	5,376,810		Hoenk et al.	12-27-1994	
	A10	5,424,549		Feldman	06-13-1995	
	A11	5,670,415		Rust	09-23-1997	
	A12	5,743,998		Park	04-28-1998	
	A13	5,855,686		Rust	01-05-1999	
	A14	5,948,219		Rohner	09-07-1999	
	A15	6,035,805		Rust	03-14-2000	
	A16	6,150,680		Eastman et al.	11-21-2000	
	A17	6,326,627	B1	Putvinski et al.	12-04-2001	
Cuy	A18	2002/0132482	A1	Chou	09-19-2002	
	A19	2002/0167117	A1	Chou	11-14-2002	
	A20	6,482,742	B1	Chou	11-19-2002	
	A21	6,534,418	B1	Plat et al.	03-18-2003	
	A22	6,541,360	B1	Plat et al.	04-01-2003	
	A23	2003/0081193	A1	White et al.	05-01-2003	
	A24	2003/0080471	A1	Chou	05-01-2003	
	A25	2004/0036201	A1	Chou et al.	02-26-2004	
	A26	5,468,542		Crouch	11-21-1995	
	A27	5,366,851		Novembre	11-22-1994	
	A28	5,362,606		Hartney et al.	11-08-1994	
	A29	5,324,683		Fitch et al.	06-28-1994	
	A30	5,212,147		Sheats	05-18-1993	
	A31	5,458,520		DeMercurio et al.	10-17-1995	
	A32	5,453,157		Jeng	09-26-1995	
	A33	5,439,766		Day et al.	08-08-1995	
	A34	5,431,777		Austin et al.	07-11-1995	
Examiner Signature	[Signature]				Date Considered	1/2005

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Substitute for form 1449A/PTO			Complete if Known		
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)			Application Number	10/788,685	
			Filing Date	02/27/2004	
			First Named Inventor	Choi et al.	
			Group Art Unit	1756	
			Examiner Name	Young, Christopher G.	
Sheet	2	of	8	Attorney Docket Number	PA130-06D09

U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
Cmg	A35	5,422,295		Choi et al.	06-06-1995	
	A36	5,421,981		Leader et al.	06-06-1995	
	A37	5,417,802		Obeng	05-23-1995	
	A38	5,380,474		Rye et al.	01-10-1995	
	A39	5,374,454		Bickford et al.	12-20-1994	
	A40	5,330,881		Sidman et al.	07-19-1994	
	A41	5,328,810		Lowrey et al.	07-12-1994	
	A42	5,318,870		Hartney	06-07-1994	
	A43	5,244,818		Jokerst et al.	09-14-1993	
	A44	5,242,711		DeNatale et al.	09-07-1993	
	A45	5,240,878		Fitzsimmons et al.	08-31-1993	
	A46	5,108,875		Thackeray et al.	04-28-1992	
	A47	5,053,318		Gulla et al.	10-01-1991	
	A48	4,964,945		Calhoun	10-23-1990	
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	A51	4,919,748		Bredbenner et al.	04-24-1990	
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	A53	6,776,094	B1	Whitesides et al.	08-17-2004	
	A54	4,201,800		Alcorn et al.	05-06-1980	
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	A60	4,707,218		Giammarco et al.	11-17-1987	
	A61	4,737,425		Lin et al.	04-12-1988	
	A62	4,808,511		Holmes	02-28-1989	
	A63	4,826,943		Ito et al.	05-02-1989	
	A64	4,857,477		Kanamori	08-15-1989	
	A65	4,891,303		Garza et al.	01-02-1990	
	A66	4,931,351		McColgin et al.	06-05-1990	
	A67	4,976,818		Hashimoto et al.	12-11-1990	
	A68	4,980,316		Huebner	12-25-1990	
Examiner Signature	Cmg				Date Considered	1/2005

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			Filing Date	02/27/2004	
			First Named Inventor	Choi et al.	
			Group Art Unit	1756	
			Examiner Name	Young, Christopher G.	
			Attorney Docket Number	PA130-06D09	
Sheet	3	of	8		

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		Number	Kind Code ² (if known)			
CJ	A69	4,999,280		Hiraoka	03-12-1991	
	A70	5,071,694		Uekita et al.	12-10-1991	
	A71	5,169,494		Hashimoto et al.	12-08-1992	
	A72	5,173,393		Sezi et al.	12-22-1992	
	A73	5,198,326		Hashimoto et al.	03-30-1993	
	A74	5,234,793		Sebald et al.	08-10-1993	
	A75	5,314,772		Kozicki et al.	05-24-1994	
	A76	5,527,662		Hashimoto et al.	06-18-1996	
	A77	5,654,238		Cronin et al.	08-05-1997	
	A78	5,700,626		Lee et al.	12-23-1997	
A79	5,736,424		Prybyla et al.	04-07-1998		
A80	5,895,263		Carter et al.	04-20-1999		
A81	5,907,782		Wu	05-25-1999		
A82	5,926,690		Toprac et al.	07-20-1999		
A83	5,948,570		Kornblit et al.	09-07-1999		
A84	6,033,977		Gutsche et al.	03-07-2000		
A85	6,096,655		Lee et al.	08-01-2000		
A86	6,150,231		Muller et al.	11-21-2000		
A87	6,245,581	B1	Bonser et al.	06-12-2001		
A88	6,274,294	B1	Hines	08-14-2001		
A89	6,329,256	B1	Ibok	12-11-2001		
A90	6,383,928	B1	Eissa	05-07-2002		
A91	6,387,783	B1	Furukawa et al.	05-14-2002		
A92	6,388,253	B1	Su	05-14-2002		
A93	6,391,798	B1	DeFelice et al.	05-21-2002		
A94	6,455,411	B1	Jiang et al.	09-24-2002		
A95	6,489,068	B1	Kye	12-03-2002		
A96	6,514,672	B2	Young et al.	02-04-2003		
A97	6,561,706	B2	Singh et al.	05-13-2003		
A98	6,565,928	B2	Sakamoto et al.	05-20-2003		
A99	2003/011368	A1	Mancini et al.	06-19-2003		
A100	2003/0129542	A1	Shih et al.	07-10-2003		
A101	6,632,742	B2	Yang et al.	10-14-2003		
A102	6,635,581	B2	Wong	10-21-2003		
Examine Signature					Date Considered	1/2005

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Sheet

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of

8

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Application Number	10/788,685
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Filing Date	02/27/2004
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First Named Inventor	Choi et al.
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Group Art Unit	1756
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Examiner Name	Young, Christopher G.
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Attorney Docket Number	PA130-06D09
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U.S. PATENT DOCUMENTS

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Sheet

5

of

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Application Number	10/788,685
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10/788,685

Filing Date	02/27/2004
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02/27/2004

First Named Inventor	Choi et al.
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Choi et al.

Group Art Unit	1756
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1756

Examiner Name	Young, Christopher G.
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Young, Christopher G.

Attorney Docket Number	PA130-06D09
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PA130-06D09

FOREIGN PATENT DOCUMENTS

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Substitute for form 1449B/PTO			Complete If Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)			Application Number	10/788,685
			Filing Date	02/27/2004
			First Named Inventor	Choi et al.
			Group Art Unit	1756
			Examiner Name	Young, Christopher G.
			Attorney Docket Number	PA130-06D09
Sheet	6	of	8	

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite ¹ No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
Cuy	A122	Abstract of Japanese Patent 63-138730	
	A123	Abstract of Japanese Patent 55-88332	
	A124	Abstract of Japanese Patent 57-7931	
	A125	Abstract of Japanese Patent 02-92603.	
	A126	Translation of Japanese Patent 02-92603.	
	A127	Abstract of Japanese Patent 02-24848.	
	A128	Translation of Japanese Patent 02-24848.	
	A129	HEIDARI et al., "Nanoimprint Lithography at the 6 in. Wafer Scale," Journal of Vacuum Science Technology, Nov/Dec 2000, pp. 3557-3560, vol. B, no. 18(6)	
	A130	NERAC.COM Retro Search, "Reduction of Dimension of Contact Holes", August 31, 2004	
✓	A131	NERAC.COM Retro Search, "Trim Etching of Features Formed on an Organic Layer", September 2, 2004	
Cuy	A132	NERAC.COM Retro Search, "Multi-Layer Resists", September 2, 2004	

Examiner Signature		Date Considered	1/2005
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**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

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Sheet 7 of 8

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OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Citation No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	†2
Cuy	A133	HU et al., "Flourescence Probe Techniques (FPT) for Measuring the Relative Efficiencies of Free-Radical Photoinitiators", s0024-9297(97)01390-9; "Macromolecules" 1998, vol. 31, no.13, pp. 4107-4113, 1998 American Chemical Society. Published on Web 05/29/1998	
↑	A134	FEYNMAN, Richard P., "There's Plenty of Room at the Bottom—An Invitation to Enter a New Field of Physics," 12 pp [online][Retrieved 9/23/04 from URL: http://www.zyvex.com/nanotech/feynman.html].	
	A135	CIBA SPECIALTY CHEMICALS BUSINESS LINE COATINGS, "What is UV Curing?", 45 pp [online][Retrieved 9/24/04 from URL: http://www.cibasc.com/image.asp?id=4040].	
	A136	Communication Relating to the Results of the Partial International Search; International Appl. No. PCT/US2002/015551.	
	A137	Papirer et al., "The Grafting of Perfluorinated Silanes onto the Surface of Silica: Characterization by Inverse Gas Chromatography," August 1993, pp238-242, vol. 159, Issue 1.	
	A138	Abstract of Papirer et al., "The Grafting of Perfluorinated Silanes onto the Surface of Silica: Characterization by Inverse Gas Chromatography," August 1993, pp238-242, vol. 159, Issue 1.	
	A139	Hirai et al., "Mold Surface Treatment for Imprint Lithography," August 2001, pp 457-462, vol 14, No. 3.	
	A140	Abstract of Hirai et al., "Mold Surface Treatment for Imprint Lithography," August 2001, pp 457-462, vol 14, No. 3.	
	A141	Sung et al., "Micro/nano-tribological Characteristics of Self-Assembled Monolayer and its Application in Nano-Structure Fabrication," July 2003, pp. 808-818, vol. 255, no. 7.	
↓	A142	Abstract of Sung et al., "Micro/nano-tribological Characteristics of Self-Assembled Monolayer and its Application in Nano-Structure Fabrication," July 2003, pp. 808-818, vol. 255, no. 7.	
Cuy	A143	Roos et al., "Nanoimprint Lithography with a Commerical 4 Inch Bond System for Hot Embossing," October 2001, pp. 427-435, vol. 4343.	

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Examiner Signature	<i>Ch. Y.</i>	Date Considered	1/2005
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